

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#11  
423-03  
ED

IN RE APPLICATION OF: Yoshihiko YANO

SERIAL NO: 09/834,950

GROUP ART UNIT: 1774

FILED: April 16, 2001

EXAMINER: Camie THOMPSON

FOR: FLUORESCENT THIN FILM, ITS FABRICATION PROCESS, AND EL PANEL

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Applicant wishes to disclose the following information.

**REFERENCES**

- The Applicant wishes to make of record the references listed on the attached Form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- A check is attached in the amount required under 37 CFR §1.17(p).

**RELATED CASES**

- Attached is a list of Applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with Form PTO-1449.
- A check is attached in the amount required under 37 CFR §1.17(p).

**CERTIFICATION**

- Each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

**DEPOSIT ACCOUNT**

- Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account Number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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Re: In re Application of: Yoshihiko YANO  
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STATEMENT OF RELEVANCY

The attached references were cited in an Official Action by the Japanese Patent Office in a corresponding foreign application. A copy of the Japanese Official Action, together with an English translation of the same, are also attached.